



#12/5074
4/12/01
7/12/01
H. L. L.

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of :

Tatsuhiko SHIBUYA et al. :

Docket No. 00774/98-129 TOK/US

Serial No. 09/302,471 :

Group Art Unit 1755

Filed April 30, 1999 :

Examiner D. Brunsmann

SILICA-BASED COATING FILM ON
SUBSTRATE AND COATING SOLUTION
THEREFOR :

THE COMMISSIONER IS AUTHORIZED
TO CHARGE ANY DEFICIENCY IN THE
FEE FOR THIS PAPER TO DEPOSIT
ACCOUNT NO. 23-0975.

PETITION FOR EXTENSION OF TIME

Assistant Commissioner for Patents,
Washington, DC 20231

RECEIVED
JUL 19 2001
TC 1700

Sir:

Petition hereby is made for a one month extension of time to respond to the communication of
February 27, 2001.

The fee of \$110.00 is

(X) submitted herewith.

() to be charged to Deposit Account No. 23-0975. A duplicate copy of this Petition is
enclosed.

() Small entity status of this application is established by the verified statement under 37
CFR 1.9 and 1.27 which

() is enclosed.

() has been previously submitted.

Respectfully submitted,

Tatsuhiko SHIBUYA et al.

06/27/2001 TGEDAMU1 00000014 09302471

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June 26, 2001